

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Tatsuya ARAO et al.)
Japanese Priority Application No. 2000-140592) Attn: Applications
Japanese Priority Date: May 12, 2000) Branch
For: SEMICONDUCTOR DEVICE AND) Date: April 5, 2001
MANUFACTURING METHOD THEREOF)



INFORMATION DISCLOSURE STATEMENT


Honorable Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99,
it is requested that the reference listed on the attached Form PTO-1449 be made of
record in the above-identified application.

A copy of this reference is submitted herewith in accordance with 37 C.F.R.
1.98(a).

Respectfully submitted,


Eric J. Robinson
Registration No. 38,285

NIXON PEABODY LLP
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102
(703) 790-9110